



DOCKET NO. US010631

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Letavic et al.) Examiner: Ngo, N.
Application No.: 10/015,640)
Filed: 12/10/2001) Art Unit: 2814
For: HIGH FREQUENCY HIGH VOLTAGE)
SILICON-ON-INSULATOR DEVICE WITH)
MASK VARIABLE INVERSION CHANNEL)
AND METHOD FOR FORMING THE SAME)

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Commissioner for Patents
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After-Final Amendment

Sir:

Introductory Comments

In response to the Final Office Action of July 31, 2003, please amend the above-identified patent application as follows:

SN: 10/015,640